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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
		:	Examiner: A.C. Stevenson
MICHIO HORIKOSHI ET AL.)	
		:	Group Art Unit: 2812
)	•
Application No.: 10/681,311		:	
)	
Filed:	October 9, 2003	:	
)	
For:	FABRICATION METHOD FOR	:	
	ELECTRON SOURCE)	
	SUBSTRATE .	:	August 4, 2004

Mail Stop Issue Fee

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE

Sir:

The issue fee being paid herewith, please amend the above-identified application as follows pursuant to 37 C.F.R. § 1.312.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 4, 2004.

(Date of Deposit)

FRANK A. DeLUCIA (REG. NO. 42,476)
(Name of Attorney for Applicant)

August 4, 2004
Date of Signature